PTO/SB/08A (10-01)

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INFO	KMA 110	N DISC	CLOSURE	Filing Date		
STAT	EMENT	BY AP	PLICANT	First Named Inventor	Manfred Albrecht	
				Art Unit		
(use as many sheets as necessary)			cessary)	Examiner Name		
Sheet	1	of	2	Attorney Docket Number	HSJ920030214US1	

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Substitute for	or form 1449B/PTO			Complete if Known		
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Sheet	2	of	2	Attorney Docket Number	HSJ920030214US1	

_		OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS	_
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue ournber(s), publisher, city and/or country where published.	T ²
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